



Docket No. 194378US-2 CONT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tetsuo TANIGUCHI

GAU: 2851

SERIAL NO: 09/618,550

EXAMINER: NGUYEN, H.

FILED: JULY 17, 2000

FOR: EXPOSURE METHOD AND LITHOGRAPHY SYSTEM, EXPOSURE APPARATUS AND METHOD OF
MAKING THE APPARATUS, AND METHOD OF MANUFACTURING DEVICE

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a two month extension of time be granted to AUGUST 21, 2002 for

- filing a response to the Official Action dated: MARCH 21, 2002
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- filing an Appeal Brief. A Notice of Appeal was filed on:
- Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$400.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

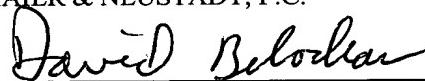
08/22/2002 SZEWDIE1 0000005 09618550

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400.00 OP

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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AUG 26 2002